## INFORMATION DISCLOSURE CITATION

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Applicants	Mitsushi IKEDA et al.					
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U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
MM	4,689,487	08/25/87	NISHIKI et al.			
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 	FOREIGN PATE	NT DOCUMENT	S		
Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)				
Y.DW	STREET, R. A. et al., "X-Ray Imaging Using Lead Iodide As A Semiconductor Detector", SPIE, Vol. 3659, pp. 36-47, (1999).			

Examiner	Krustu N-	Date Considered 9/20/05
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